

PATENT Attorney Docket No.: <u>AUB-06300</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For:

METHOD OF PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF DIAMOND USING

DIAMOND USING METHANOL-BASED

SOLUTIONS

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

) Art Unit: 1762
) Examiner: Stouffer, Kelly M.
)
) REQUEST FOR A ONE MONTH
) EXTENSION OF TIME

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Customer Number 28960

Applicants hereby petition for a three (3) month extension of time to answer the outstanding Office Action mailed November 22, 2006 regarding the above-identified patent application. Please find a check enclosed in the amount of \$905.00 (\$395.00 to cover the request for continued examination, plus \$510.00 to cover the three month extension of time filing fee).

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: May 11, 2007

Jonathan O. Owens Reg. No.: 37,902

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510.00 OP

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient pustage as first class mail in an envelope addressed to the:
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Date: 5/11/07 m. M. Man Lelna